

OFFICIAL

**PATENT**

Attorney Docket No. 007996 USA CO1/IMPLANT/CONDUCTIVE/JB1 [as amended]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****RECEIVED**  
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In re application of: Donald W. Berrian  
Application No.: 10/694,162  
Filed: 27 October 2003

Group No.: 2881  
Examiner: Vanore, David A.  
Conf. No.: 3050

JUN 17 2004

For: **SYSTEM AND METHOD FOR IMPLANTING A WAFER WITH AN  
ION BEAM**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST TO CHANGE CORRESPONDENCE ADDRESS**

Please change the Correspondence Address for the above-identified application to:

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I am the attorney of record.

Respectfully submitted,

Date: 17 June 2004

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**CERTIFICATE OF TRANSMITTAL UNDER 37 C.F.R. 1.8**

I hereby certify that, on the date shown below, this correspondence is being transmitted to facsimile number 703-872-9306 via facsimile to: TC2800, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

June 17, 2004  
Date

Janice Price  
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